

IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Group Art Unit: 2822

Khalil Najafi, et al.

Examiner:

Serial No.: 10/688,417

Filed: October 17, 2003

For: MANUFACTURING METHODS AND VACUUM OR HERMETICALLY
PACKAGED MICROMACHINED OR MEMS DEVICES

Attorney Docket No.: UOM 0281 PUSP

STATUS INQUIRY

Commissioner for Patents
U.S. Patent & Trademark Office
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please inform us of the status of the above-identified patent application and as to when we may expect an Office Action from the U.S. Patent and Trademark Office.

Respectfully submitted,

Khalil Najafi, et al.

By: 

David R. Syrowik
Reg. No. 27,956
Attorney/Agent for Applicant

Date: January 13, 2005

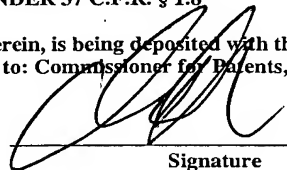
BROOKS KUSHMAN P.C.
1000 Town Center, 22nd Floor
Southfield, MI 48075-1238
Phone: (248) 358-4400
Fax: (248) 358-3351

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

I hereby certify that this paper, including all enclosures referred to herein, is being deposited with the United States Postal Service as first-class mail, postage pre-paid, in an envelope addressed to: Commissioner for Patents, U.S. Patent & Trademark Office, P.O. Box 1450, Alexandria, VA 22313-1450 on:

January 13, 2005
Date of Deposit

David R. Syrowik
Name of Person Signing


Signature